

**Notice of References Cited**

Application/Control No.

09/342,348

Applicant(s)/Patent Under  
Reexamination  
BROSNIHAN ET AL.

Examiner

Anh D. Mai

Art Unit

2814

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*		Document Number	Date	Name	Classification	
		Country Code-Number-Kind Code	MM-YYYY			
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	B	US-6,046,067-	04-2000	Werner	438	52
	C	US-5,565,625-	10-1996	Howe et al.	73	514.16
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	K	US- -				
	L	US- -				
	M	US- -				

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		Country Code-Number-Kind Code	MM-YYYY				
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**NON-PATENT DOCUMENTS**

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	V	Bronihan T. et al., Embedded Interconnect and Electrical Isolation for High-Aspect-Ration, SOI inertial Instruments., 1997, IEEE, pp. 637-640.
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\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.